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FROM:

Tung & Associates

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DATE:

29 November 2003

REF:

Applicant : Hsieh et al.

Filing Date: 11 October 2001

Serial No : 09/975,855

Att'y No. : 67,200-447

Art Unit Title

1756

Examiner: Saleha R Mohamedulla

: Gap Forming Pattern Fracturing Method for Forming Optical

Proximity Corrected Masking Layer

## AMENDMENT AND RESPONSE TO OFFICE ACTION

Sir:

In response to an office action mailed on 10 October 2003, please consider the following amendments and remarks pertaining to the above referenced application.

Amendments to the specification begin on page 2 of this paper. Amendments to the claims are found within a Listing of the Claims that begins on page 3 of this paper. Amendments to the drawings begin on page 7 of this paper. Remarks begin on page 8 of this paper. BEST AVAILABLE COPY.

**CERTIFICATE OF MAILING** 

I hereby certify that this correspondence is being forwarded in an envelope with sufficient postage as first class mail to the Commissioner for Patents, POB 1450, Alexandria, VA

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22313-1450 on Dec. 23